

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	
	:	
Yoshiharu OHTA	:	Confirmation No. 9499
	:	
U.S. Patent Application No. 10/594,475	:	Group Art Unit: 1793
	:	
Filed: September 28, 2006	:	Examiner: Michael A. MARCHESCHI

For: SEMICONDUCTOR POLISHING COMPOSITION

**EXPRESS ABANDONMENT**

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

I request that the above-identified application be expressly abandoned, without prejudice or disclaimer, as of the filing date of this paper.

I am an attorney of record. My attorney registration number is 45,943.

The Examiner's position in the Answer is duly noted. Applicants do not agree, and no one should draw any adverse inference from the decision to expressly abandon. This decision is related to business, not the merits of anything said in this record.

Respectfully submitted,

**LOWE HAUPTMAN HAM & BERNER, LLP**

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**September 7, 2010**